



Attorney's Docket No.: 6245 USA/TCG/EPI

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Jean R. Vatus et al.

U.S. Serial No: 10/078,071

Filed: February 13, 2002

For: A METHOD OF CALIBRATING AND
USING A SEMICONDUCTOR PROCESSING
SYSTEM

Examiner: Unknown

Art Unit: Unknown

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS INQUIRY UNDER MPEP 203.08

Sir:

Applicant respectfully requests information concerning the status of this application. No correspondence has been received from the Patent and Trademark Office since the filing of this application on February 13, 2002 (except for the returned postcard and filing receipt).

Please provide to the Applicant, by written response, an expected date of when the Examiner will take action on this application.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date: 4/1/04

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, PO Box 1450, Alexandria, Virginia 22313-1450

on April 2, 2004

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